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# Flexible urea sensor fabrication by localized laser - induced pyrolysis of Kapton

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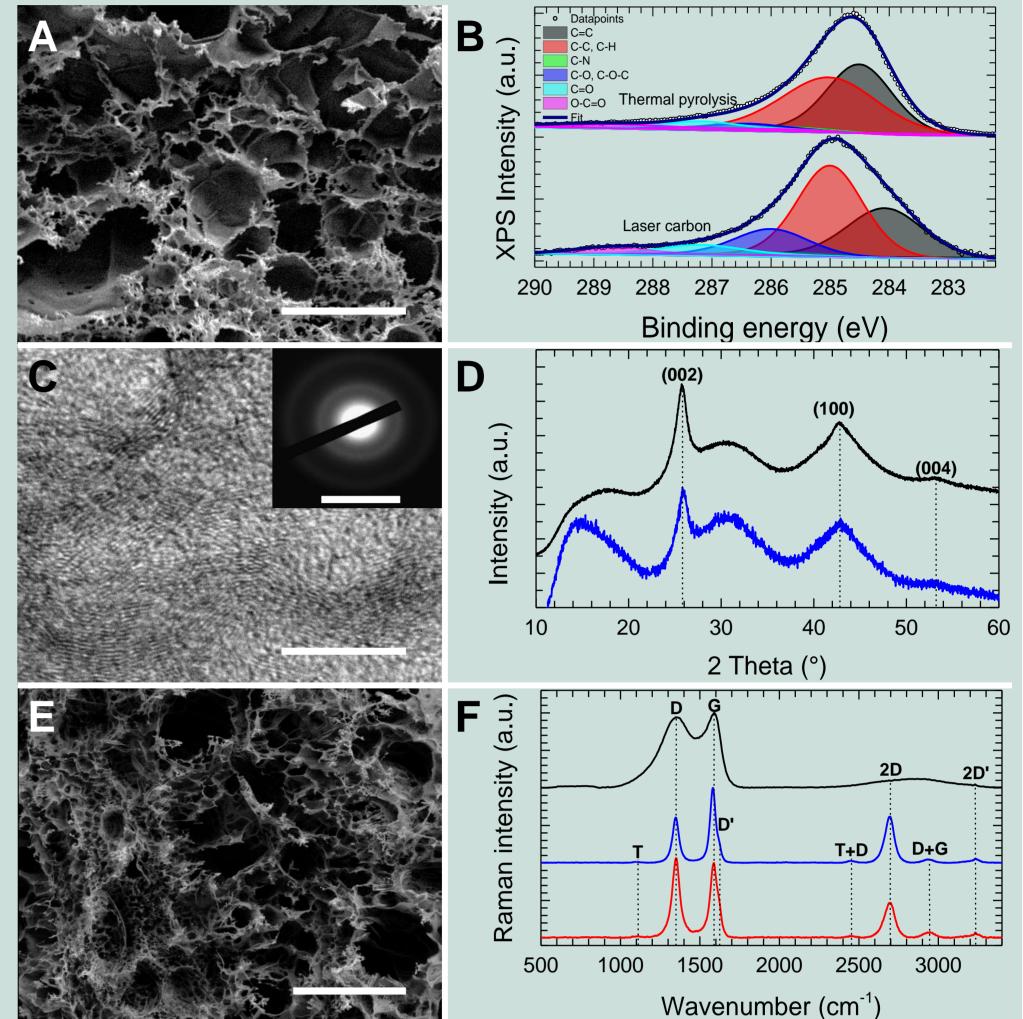
### Introduction

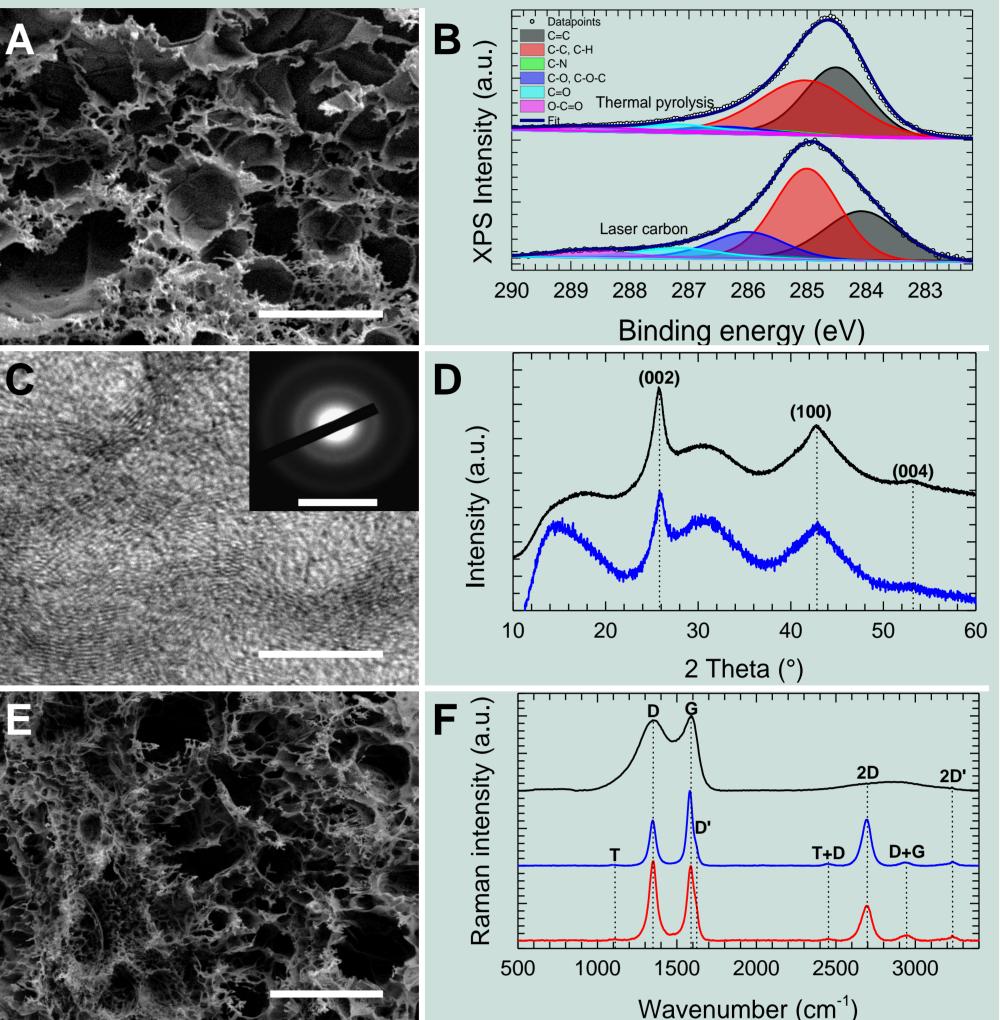
We present a fabrication method of enzymatic urea sensor employing new, low-cost, lithography free, one-step process of laserinduced carbonization [1-4] and compare it to glassy carbon [5].

## **Carbon electrode fabrication and characterization**

**Fabrication:** 

- Kapton<sup>™</sup>HN 125±13µm;
- $CO_2$  laser, wavelength 10.6 $\mu$ m;
- Power 4.8 W, speed 10 cm/s.





Here, we report fabrication of two types of enzymatic urea sensors by immobilization of urease:

- directly on carbon;
- via intermediate biopolymer (chitosan) layer.

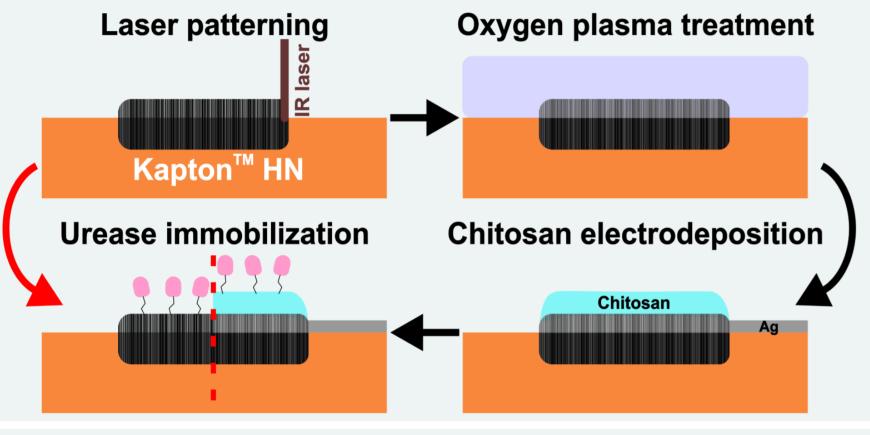


Fig. 1. Flow chart of the process

### **Properties:**

- High porosity:
  - BET surface area  $255 \text{ m}^2/\text{g};$
- Surface porosity 15.2%;
- Composition:
- XPS: C 76.1%, N 1.0%, O 23.0%;
- Combustion analyzer: C 93%, N–0.9%, H – 0.4%;
- Conductivity 7.1±0.7 S/cm;
- *d*-spacing 3.48Å;  $L_a = 4.0$ nm;  $L_c = 7.1$ nm;
- Raman ratio  $(I_D/I_G) 0.8;$
- Hydrophilicity (contact angle 70°).

Fig. 2. (A) SEM image of fabricated laser carbon ([scale bar] =10µm); (B) XPS spectra C 1s line; (C) TEM image of laser carbon and corresponding selected area diffraction, ([scale bar] = 10 nm, [SAED]=10 1/nm) (**D**) powder X-ray diffractrogram collected from powder; (E) morphology after oxygen plasma treatment ([scale bar] =  $10 \mu m$ ); (F) Raman spectra. In all cases in black thermally pyrolysed Kapton at 900°C, blue - laser carbon, red – laser carbon after oxygen plasma treatment

# Chitosan electrodeposition and process optimization

- Chitosan preparation: chitosan solution 1 % w/v, pH 5.5 A in diluted HCI (0.2 M) and filtered,
- Improvement of hydrophilicity

- Oxygen plasma treatment at 100 W for 120s
- Contact angle <10°;
- Retention over 5 days;
- Highest deposition quantity at current direction perpendicular to laser patterning;
- Optimal deposition duration is 15 min at 4  $A/m^2$ . Increase of the time leads to chitosan self-peeling;
- Chitosan film thickness  $\sim 2 \,\mu m$  after drying.

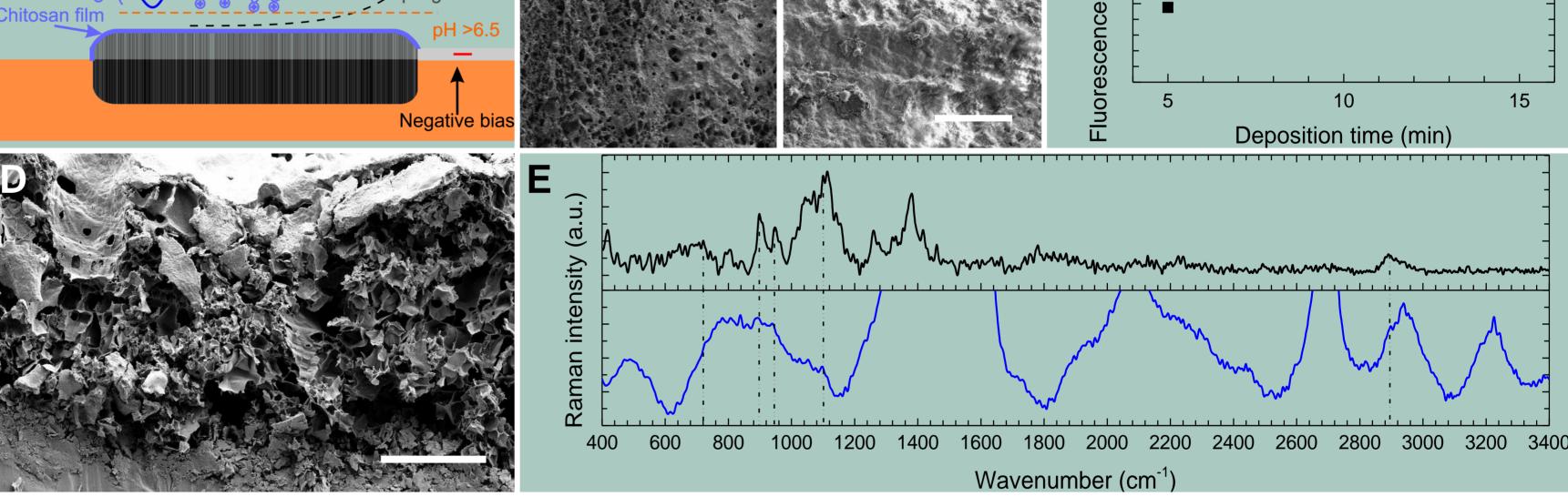


Fig. 3. (A) Scheme of chitosan electrodeposition. (B) Electrodeposited chitosan on laser carbon with applied current (left) parallel and (right) perpendicular to laser patterning direction ([scale bar] = 50 µm). (C) Quantity of chitosan deposition over time of attached chitosan determined with fluorescence microscopy. (D) Cross-sectional SEM. (E) Raman spectra collected from chitosan film deposited on gold (black) and on carbon electrode (blue)

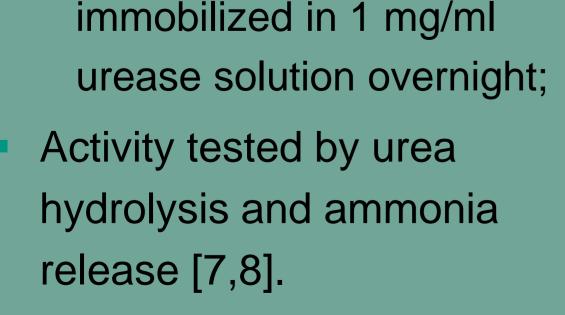
### **Urea sensor fabrication and analysis Urease from Jack Beans** (Canavalia ensiformis): Covalently coupled to chitosan with glutaraldehyde **50** sec after (Sigma Aldrich 25% in **E** 10.0 **D**<sup>10.0</sup> All sensors were

# Conclusions

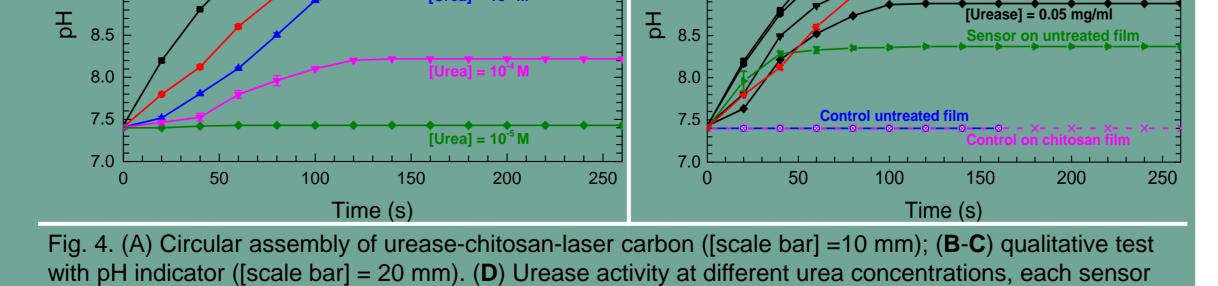
Material exhibits electrical, mechanical and physical properties different from glassy carbon.

Simplicity, flexibility and versatility of such method enable:

- fabrication of the patterns of various designs;
- variation of the properties dependent on applied laser parameters;



water) [6];



was coated with 1 mg/ml of initial urease concentration. (E) Comparison of urease activity to control solutions of various urea concentrations (*black*) and test sensors: urease-chitosan-laser carbon (*red*) and urease - laser carbon (green)

### electrodeposition of chitosan can be utilized for immobilization of other enzymes;

- determined urea detection limit at 10<sup>-4</sup>M, which is in two orders below risk values for a healthy human;
- integration with other biomedical devices, *e.g.* in catheter tube (4 mm diameter tested).

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